

Application Data Sheet

Application Information

Application Type:: Regular
Subject Matter:: Utility
Suggested classification::
Suggested Group Art Unit::
CD-ROM or CD-R?:: None
Computer Readable Form (CRF)?:: No
Title:: PROCESS FOR LINING A SURFACE
USING AN ORGANIC FILM
Attorney Docket Number:: 355901-0110
Request for Early Publication?:: No
Request for Non-Publication?:: No
Suggested Drawing Figure:: 1
Total Drawing Sheets:: 6
Small Entity?:: No
Petition included?:: No
Secrecy Order in Parent Appl.?:: No

Applicant Information

Applicant Authority Type:: Inventor
Primary Citizenship Country:: France
Status:: Full Capacity
Given Name:: Christophe
Family Name:: Bureau
City of Residence:: Suresnes

Country of Residence::	France
Street of mailing address::	24, rue de la liberté Suresnes
	France F-92150
Country of mailing address::	France
Applicant Authority Type::	Inventor
Primary Citizenship Country::	France
Status::	Full Capacity
Given Name::	Guy
Family Name::	Deniau
City of Residence::	Auffargis
Country of Residence::	France
Street of mailing address::	5, allée de la ferme Auffargis
	France F-78610
Country of mailing address::	France
Applicant Authority Type::	Inventor
Primary Citizenship Country::	France
Status::	Full Capacity
Given Name::	Serge
Family Name::	Palacin
City of Residence::	Montigny le Bretonneux
Country of Residence::	France
Street of mailing address::	21, rue Antoine Coysevox Montigny le Bretonneux
	France F-78180
Country of mailing address::	France

Correspondence Information

Correspondence Customer Number:: 38706

E-Mail address:: PTOMailSiliconValley@foley.com

Representative Information

Representative Customer Number::	38706	
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Domestic Priority Information

Application::	Continuity Type::	Parent Application::	Parent Filing Date::
This Application	National Stage of	PCT/FR2003/50035	8/25/2003

Foreign Priority Information

Country::	Application number::	Filing Date::	Priority Claimed::
France	FR 02 10568	8/26/2002	Yes

Assignee Information

Assignee Name:: Commissariat a L'Energie Atomique